



Attorney's Docket No.: 07977-046002 / 3041/3050/3059/30

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : 1765
Serial No.: 09/304,523 Examiner : Robert Kunemund
Filed : May 4, 1999
Title : METHOD AND APPARATUS FOR PRODUCING SEMICONDUCTOR
DEVICE

Commissioner for Patents
Washington, D.C. 20231

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OCT 15 2001

RESPONSE

In response to the action mailed June 1, 2001, please amend
the application as follows:

In the Drawings:

Please enter the changes shown in red ink on the enclosed
copy of Figure 5. Applicants have removed the legend "Prior
Art," as the figure is not a prior art drawing, as described in
the Specification on page 24, lines 19-23.

In the claims:

Please amend claim 7, 9, 10, 12, 13, 15, 16, 18, 19, 21,
22, and 24 as follows:

7. (Amended) A method of manufacturing a semiconductor
device comprising the steps of:
forming a semiconductor film over an upper surface of
a substrate;

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02 FC:103
03 FC:102

288.00 OP
252.00 OP

CERTIFICATE OF MAILING BY FIRST CLASS MAIL
I hereby certify under 37 CFR §1.8(a) that this
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